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# **Tuning Fermi Level Beyond the Intrinsic Equilibrium Doping Limit through Quenching: the Case in CdTe**

Ji-Hui Yang<sup>1</sup>, Ji-Sang Park<sup>1</sup>, Joongoo Kang<sup>2</sup>, Wyatt Metzger<sup>1</sup>, Teresa Barnes<sup>1</sup>, and Su-

Huai Wei<sup>1\*</sup>

<sup>1</sup> National Renewable Energy Laboratory, Golden, CO 80401, USA

<sup>2</sup> Department of Emerging Materials Science, DGIST, Daegu 711-873, Korea

## **Abstract**

The Fermi level of a material is a fundamental quantity that determines its electronic properties. Thus, the ability to tune Fermi levels is important for developing electronic device materials. However, for most materials, the Fermi level is limited to a certain range in the bandgap due to the existence of certain intrinsic compensating defects. Here we demonstrate that quenching can be used as an effective way to overcome this limit, allowing the Fermi levels to be tuned in a much wider range. Taking a photovoltaic material, CdTe, as a prototype example, we analyzed the physical origin of Fermi level pinning and explained why growing the sample at high temperature followed by rapid quenching to room temperature can overcome the self-compensation limit. We further show that for CdTe, quenching can increase the Fermi level range from about 0.6 eV to 1.1 eV, which has a great potential in improving CdTe solar cell performance. Our proposed strategy of tuning Fermi level positions beyond the intrinsic equilibrium doping limit is general and can be applied to other semiconductor systems.

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## I. INTRODUCTION

The Fermi level position ( $E_F$ ) of a material is a fundamental quantity that plays a key role in determining its functionality. Therefore, it is desirable that  $E_F$  can be well controlled and tuned in a wide range to satisfy requirements for some specific applications. For example, in topological insulators,  $E_F$  needs to be controlled close to the Dirac-point for physical studies and practical applications [1-4]. In thermoelectric materials,  $E_F$  should be tuned to maximize the figure of merits [5-8]. In photovoltaic (PV) materials,  $E_F$  needs to be tuned in a range as large as possible to obtain high diffuse voltages, which give high open circuit voltages. It's well known that for a pristine material with the exact stoichiometry,  $E_F$  is pinned near the middle of the band gap, because the amounts of thermally excited electrons and holes are always the same. In reality, intrinsic defects are formed during material growth and  $E_F$  can vary in a certain range by controlling the growth conditions. However, due to the self-compensation effect, the variation of  $E_F$  is often limited: outside of a certain  $E_F$  range, some compensating defects can form more easily than others, thus returning  $E_F$  back under the equilibrium growth conditions. So far, most of the studies on overcoming the doping limit [9-18] focus on enhancing solubility of desirable intrinsic defects under equilibrium growth conditions or on obtaining proper transition energy levels through co-doping or extrinsic doping. Little was discussed about overcoming Fermi level pinning. The importance of  $E_F$  in electronic applications necessitates the exploration of new approaches for overcoming the doping limit and tuning  $E_F$  more efficiently.

Specifically, In PV materials such as CdTe, Cu(In,Ga)Se<sub>2</sub>, and Cu<sub>2</sub>ZnSn(S,Se)<sub>4</sub>,  $E_F$  is required to cover a range as large as possible, which means,  $E_F^n$  and  $E_F^p$ , the Fermi energy levels referenced to the valence band maximum (VBM) for n-type and p-type doped layers, respectively, need to be tuned towards as close as possible to the respective band edges. Because the difference  $\phi_D = (E_F^n - E_F^p)/q$ , where  $q$  is electron charge and  $\phi_D$  is the diffusion voltage at the homogeneous p-n junction of this material (Fig. 1), is proportionally related to the open circuit voltage ( $V_{OC}$ ) of the solar cells. However, under equilibrium intrinsic growth conditions, the variation of

$E_F^p$  or  $E_F^n$  are often limited, especially if some defects have very low formation energies. For example, antisite cation acceptors in multi-cation compounds [19, 20] can form easily, which pins the  $E_F^n$  close to the VBM, leading to small  $\phi_D$  and  $V_{OC}$  compared to their band gaps [21]. These deficiencies of  $V_{OC}$  have now become hindrances for the further improvement of these solar cells' performances.

Here, we take CdTe as a prototype system to reveal the origins of Fermi level pinning and to discuss possible strategies for increasing the range of  $E_F$  beyond intrinsic limits. As one of the most important thin-film solar cell materials with relatively low cost and high efficiency, CdTe has recently reached an efficiency of 20.4% by First Solar [22]. However, this is still far from its theoretical maximum efficiency ( $\sim 30\%$ ). A major limiting factor is its low  $V_{OC}$ , which is only about 0.85 eV, much smaller than its bandgap. Therefore, to further improve CdTe solar cell efficiency, reasons behind such a small  $V_{OC}$  need to be revealed and possible solutions are suggested.

In this paper, we first investigate the intrinsic defect properties of CdTe using first-principles calculations and explained why  $V_{OC}$  of CdTe solar cell is small. Then using thermo dynamical theory of defects, we quantitatively study the Fermi level splitting in CdTe under equilibrium growth conditions. By understanding the Fermi Level splitting mechanism, we propose a non-equilibrium quenching method for overcoming the  $E_F$  and  $V_{OC}$  limitation. Our quantitative study shows that  $\phi_D$  of CdTe solar cell can reach as high as 1.1 eV after quenching, which has great potential to improve the energy conversion efficiency.

## II. CALCULATION METHODS

Our first-principles total energy and band structure calculations were performed using density functional theory (DFT) [23,24] as implemented in the VASP code [25,26]. The electron and core interactions are included using the frozen-core projected augmented wave (PAW) approach [27]. To correct the band gap error, the Heyd-Scuseria-Ernzerhof (HSE06) hybrid functional [28] is used. The defect calculations are performed within a 64-atom supercell where all the atoms in the

supercell are fully relaxed till the forces on every atom are less than 0.05 eV/Å. The total energy is calculated with  $2 \times 2 \times 2$  Monkhorst-Pack special k-point meshes and Gaussian smearing method (SIGMA=0.02) to make sure it's converged within 0.1 eV using an energy cutoff of 300 eV. The defect properties are calculated using the scheme in Ref. 9. Using the HSE06 functional with the default exchange parameters ( $\alpha=0.25$ ), the calculated lattice constant of pure CdTe is 6.58 Å with a band gap of 1.49 eV, in good agreement with the experiments [29].

### III. INTRINSIC DEFECT PROPERTIES OF CdTe

Fig. 2 shows the intrinsic defect formation energies as a function of  $E_F$  under Cd-rich and Te-rich growth conditions. Compared to previous calculations [30], our results mainly show two different characters. First, the transition energy level of Cd vacancy from 0 to  $-2$  is 0.36 eV above the valence band maximum (VBM) of CdTe, making it a relatively deep acceptor. The relatively deep acceptor level is caused by the large local structure distortion around  $V_{Cd}$  at the neutral charge state, where two Te get closer and the other two Te get farther, thus splitting the three fold degenerated defect states under  $T_d$  symmetry to two degenerated fully occupied states and one unoccupied state. The upshift of this unoccupied state makes it costing more energy to accept two electrons from VBM, leading to the relatively deep transition level of  $V_{Cd}$ . Another different result is that  $V_{Te}$  becomes a rather shallow and dominant donor with the  $(2+/0)$  transition energy level above the conduction band minimum (CBM). This shallow donor level is caused by large atomic displacement of Cd atoms around this defect when the defect becomes charged [31]. We see that, under equilibrium growth conditions,  $E_F^p$  will be bounded around point A and  $E_F^n$  will be bounded around point B, yielding a diffuse voltage of about 0.6 eV. The exact Fermi energy at finite temperature, however, will depend on the generated defect densities as well as thermally excited electron and hole concentrations.

### IV. THERMODYNAMIC SIMULATIONS UNDER EQUILIBRIUM GROWTH CONDITIONS

Under thermodynamic equilibrium growth conditions and within the dilute limit, the density of a defect  $\alpha$  with charge state  $q$  can be calculated as:

$$n(\alpha, q) = N_{site} g_q e^{-\Delta H_f(\alpha, q)/k_B T}, \quad (1)$$

where,  $N_{site}$  is the number of possible sites per volume for defect  $\alpha$ ,  $g_q$  is the degeneracy factor related to possible electron occupations [32,33], and  $\Delta H_f(\alpha, q)$  is the formation energy of a defect  $\alpha$  at charge state  $q$ . Here  $\Delta H_f(\alpha, q)$  is defined as [9]:

$$\Delta H_f(\alpha, q) = E(\alpha, q) - E(host) + \sum_i n_i (E_i + \mu_i) + q[\epsilon_{VBM}(host) + E_F], \quad (2)$$

which is a function of chemical potentials  $\mu_i$  of involved elements and Fermi level  $E_F$ . At a given temperature, the thermally excited electron density  $n_0$  and hole density  $p_0$  are also functions of Fermi level, which are given as:

$$\begin{aligned} n_0 &= N_c e^{-\frac{E_c - E_F}{k_B T}}, N_c = 2 \frac{(2\pi m_n^* k_B T)^{3/2}}{h^3}, \\ p_0 &= N_v e^{-\frac{E_F - E_v}{k_B T}}, N_v = 2 \frac{(2\pi m_p^* k_B T)^{3/2}}{h^3}. \end{aligned} \quad (3)$$

Here,  $N_c$  is the temperature-dependent effective density of states of the conduction band that can accept electrons and  $N_v$  is the effective density of states of the valence band that can accept holes.  $m_n^*$  ( $0.095 m_0$  for CdTe) and  $m_p^*$  ( $0.84 m_0$  for CdTe) are effective masses of electrons and holes, taking into account of spin degeneracy and spin-orbital coupling [33,34]. The neutralization condition in a semiconductor system with defects requires that:

$$p_0 + \sum_i q_i n_{D_i}^{q_i+} = n_0 + \sum_j q_j n_{A_j}^{q_j-}, \quad (4)$$

where  $n_{D_i}^{q_i+}$  is the density of a donor  $D_i$  with charge state  $q_i$  and  $n_{A_j}^{q_j-}$  is the density of an acceptor  $A_j$  with charge state  $-q_j$ . By solving equations in (1)-(4) self-consistently, we can obtain the  $E_F$  of a semiconductor system at given chemical potentials, as well as carrier densities and defect densities, when this material is grown under equilibrium conditions at a given growth temperature.

Our simulations for CdTe are shown in Fig. 3. As can be seen in the left panels, at  $T=300$  K, the Fermi level of CdTe is generally pinned in the middle of bandgap [Fig.

3(a)]. This is because equilibrium defect densities in CdTe are very low ( $<10^6/cm^3$ ) at this temperature so intrinsic thermal excitation process dominate with  $N_c \sim 10^{17}/cm^3$  and  $N_v \sim 10^{19}/cm^3$ . As the growth temperature increases to 800K and 1200 K, more defects can be created and band edge excitation becomes less dominant, so the  $E_F$  is pushed down for p-type doping (under Cd-poor conditions) or up for n-type doping (under Cd-rich conditions), enlarging the variation range of  $E_F$ . Notice that the  $E_F$  only shifts slightly even though the defect density has increased by more than ten orders of magnitude. This is because the effective band edge density of states and band to band thermal excitation also increase significantly at a high temperature, so the  $E_F$  is still primarily controlled by the band edge excitation. However, no matter how high the growth temperature is, the  $E_F$  will be pinned around 0.7 eV or near position A in Fig. 2(a) for p-type doping, which is the lowest  $E_F$  achievable for p-type CdTe under thermodynamic equilibrium growth conditions. This is because if  $E_F$  is lower than A, the formation energy of  $V_{Te}^{2+}$  would be lower than that of  $V_{Cd}^{2-}$ , thus more  $V_{Te}^{2+}$  would form than  $V_{Cd}^{2-}$ , pushing the Fermi level up. Similarly, for n-type doping, the Fermi level will be pinned around 1.3 eV or position B in Fig. 2(b), which is the highest Fermi level for n-type CdTe under equilibrium growth conditions. As a result of this intrinsic self-doping limit, the largest possible  $\phi_D$  of CdTe solar cells grown under equilibrium conditions will be limited by the Fermi level difference between the two pinning points A and B, which is only about 0.6 eV.

To overcome the Fermi energy limit and widen the  $E_F$  range, other methods such as non-equilibrium growth approaches should be considered. Notice that the shift of  $E_F$  is determined largely by the excess electrons or holes from the dominant intrinsic defects. To increase excess carriers from a particular intrinsic defect, high temperatures are often necessary to simultaneously generate the defects and shift the  $E_F$  to a desirable position. However, to increase electrons-to-holes ratio and shift the  $E_F$  towards the band edges, thermal excitations from the band edges must be reduced, which can only be achieved at a low temperature. Therefore, quenching may be a strategy to overcome the  $E_F$  pinning caused by defect self-compensation. After quenching at a given growth chemical potential, intrinsic defects can dominate over

thermal excitations and one type of defects (acceptor or donor) can dominate over the others, thus shifting the  $E_F$  to either its acceptor transition energy level and valence band or its donor transition energy level and conduction band.

## V. THERMODYNAMIC SIMULATIONS AFTER QUENCHING

When rapidly quenching to a low temperature (e.g., room temperature), the total density of a defect  $\alpha$  generated at a high temperature, which is the sum of densities of  $\alpha$  with all possible charge states, is assumed to be unchanged. The only possible change after the rapid quenching is the redistribution of defect densities at different charge states. For example, considering a defect  $\alpha$  with two charge states 0 and  $q$ , the density of  $\alpha$  with charge state  $q$  is recalculated as:

$$n'(\alpha, q) = N_\alpha \times \frac{g_q e^{-\Delta H_f(\alpha, q)/k_B T}}{g_q e^{-\Delta H_f(\alpha, q)/k_B T} + g_0 e^{-\Delta H_f(\alpha, 0)/k_B T}}, \quad (5)$$

where  $N_\alpha$  is fixed as the total number of defect  $\alpha$  at growth temperature. By solving all equations in (2)-(5) self-consistently, we can get a new set of  $E_F$ , carrier densities, and defect densities with different charge states after the sample is quenched.

The right panels of Fig. 3 show the Fermi levels, carrier densities and defect densities as functions of the Cd chemical potential after quenching in CdTe. The hole density for p-type CdTe after quenching is on the order of  $10^{14}/\text{cm}^3$ , which agrees well with experiments. Notably, for p-type CdTe grown under Cd-poor conditions, the  $E_F^p$  is lowered after quenching while for n-type CdTe under Cd-rich conditions, the  $E_F^n$  is raised (See also Fig. 4). Our results are consistent with the previous work of M. A. Berding [35], in which Fermi level splitting in CdTe is also found to be enlarged after quenching, although in her local density approximation (LDA) calculation, the band gap is severely underestimated. Therefore, our calculations show that in the case of CdTe, after quenching from high growth temperatures, both  $E_F^n$  and  $E_F^p$  can be tuned beyond the self-doping limit under equilibrium growth conditions.

## VI. DISCUSSIONS

The reason that  $E_F^p$  is pushed significantly past A after quenching under Cd-poor



conditions can be understood as follows. At high growth temperatures with Cd-poor conditions,  $V_{Cd}^{2-}$  has a very low formation energy because the Fermi level is pinned at a position higher than A due to thermal excitation [Fig. 2(a)]. Therefore, it is dominant and has a much higher density than other defects. After quenching, the thermally excited electrons from the VBM to the conduction band maximum (CBM) of CdTe are dramatically reduced, but the existence of large amounts of  $V_{Cd}$  with negatively charged states close to the VBM makes holes dominant over electrons, thus pushing the Fermi level down towards the (0/2-) transition energy level of  $V_{Cd}$  at 0.36 eV and VBM. In this case, the defect level acts as a new “CBM” state when the defect density is high and the total density of  $V_{Cd}$  acts as “ $N_c$ ”. As is shown in Fig. 4(b), the quenched Fermi level initially decreases as the growth temperature increases, from 0.38 eV (600 K) to 0.35 eV (700 K) to 0.34 eV (800 K). This is due to the increased defect density of  $V_{Cd}$  as the growth temperature increases. However, further increases of growth temperature leads to an increase of the Fermi energy [Fig. 4(b)]. Because at very high growth temperatures, the densities of donor defects such as  $Te_{Cd}^{2+}$  and  $V_{Te}^{2+}$  also increase significantly, leading to the slight increase in Fermi level after quenching. Besides,  $Te_{Cd}$  has a deep (2+/0) transition energy level, and thus can serve as recombination centers, therefore, its density should be suppressed by either lowering growth temperature or growing CdTe under Cd-rich conditions. After taking all the above factors into consideration, we suggest that it's best to grow p-type doped CdTe at 800 K with  $\mu_{Cd} \sim -1.0$  eV, which gives an  $E_F^p$  of about 0.35 eV after quenching. Further tuning down of  $E_F^p$  can only be achieved by extrinsic impurities, which may create shallower transition energy levels than  $V_{Cd}$ .

The reason why  $E_F^n$  is tuned beyond B after quenching under Cd-rich conditions is analogous to the previous mechanism. At high growth temperatures with Cd-rich conditions, fully ionized  $V_{Te}^{2+}$  is the dominant defect because the Fermi energy is pinned close to the bandgap center [Fig. 2(b)]. After quenching, the thermally excited electrons and holes from the VBM to the CBM of CdTe are dramatically reduced. The high density of  $V_{Te}^{2+}$  makes electrons dominant over holes and shifts the Fermi level towards the CBM. In this case, the hole density at the VBM disappears and the defect

level of  $V_{Te}$  acts as a new “VBM” state and the total density of  $V_{Te}$  acts as “ $N_v$ ”. We note that the quenched  $E_F^n$  increases as the growth temperature increases. This is because the  $(2+/0)$  transition energy level of  $V_{Te}$  and  $Cd_{Te}$  is above the CBM, so  $V_{Te}$  is always in the  $2+$  charged ionized state. The higher the growth temperature, the more  $V_{Te}^{2+}$  will be formed under equilibrium growth conditions. After quenching,  $V_{Te}^{2+}$  passivates the holes at the VBM and pushes the Fermi level upwards. Importantly, there are no low energy acceptor defects which can donate extra holes after Fermi energy increases, therefore, the quenched  $E_F^n$  is only limited by the CBM.

Our analysis suggests that quenching can selectively enhance the defect density of the desired dopants and suppress the undesired dopants, and therefore is an effective strategy to overcome Fermi level pinning caused by intrinsic defect self-compensation. By quenching,  $E_F^p$  has been significantly tuned downwards and  $E_F^n$  is pushed upward, thus,  $\phi_D$ , as well as the  $V_{OC}$ , is increased towards the band gap value. According to our calculations, if p-type CdTe is grown at 800 K at Cd-poor conditions, a Fermi level of 0.35 eV above the VBM can be obtained; likewise if n-type CdTe is grown at 1200 K under Cd-rich conditions, a quenching Fermi level of 1.42 eV can be achieved. Therefore a  $\phi_D$  of 1.07 eV is, in principle, achievable by intrinsic doping alone, which could significantly improve the energy conversion efficiency of CdTe solar cells. In general, quenching from a higher growth temperature can lead to a higher  $\phi_D$  [Fig. 4(b)] or larger Fermi level ranges. However, in practice, the growth temperature may be limited by factors such as melting point of the glass substrates thus limiting the achievable  $\phi_D$  and  $V_{OC}$ .

## VII. CONCLUSION

In conclusion, we have proposed a novel, effective, non-equilibrium quenching method for overcoming the  $E_F$  limitation caused by self-compensation of intrinsic defects in semiconductor materials and make  $E_F$  cover a much wider range of the bandgap. By applying this approach to CdTe, we show that the Fermi level range, thus the diffusion voltage  $\phi_D$ , can increase significantly from about 0.6 eV to about 1.1 eV, which, therefore, has the potential to significantly improve its solar cell performance.

The proposed strategy of tuning Fermi level positions beyond the intrinsic doping limit is based on simple thermodynamics, so it is general and can be applied to other semiconductor systems.

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e-mail: [Suhuai.Wei@nrel.gov](mailto:Suhuai.Wei@nrel.gov)

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## Figures

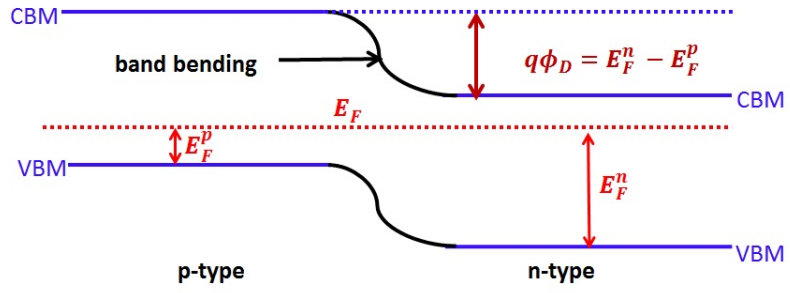


FIG. 1 (color online). Schematic diagram to show that diffusion voltage  $\phi_D$  is determined by the Fermi level differences  $q\phi_D = E_F^n - E_F^p$ , which is bounded by the bandgap of the material.

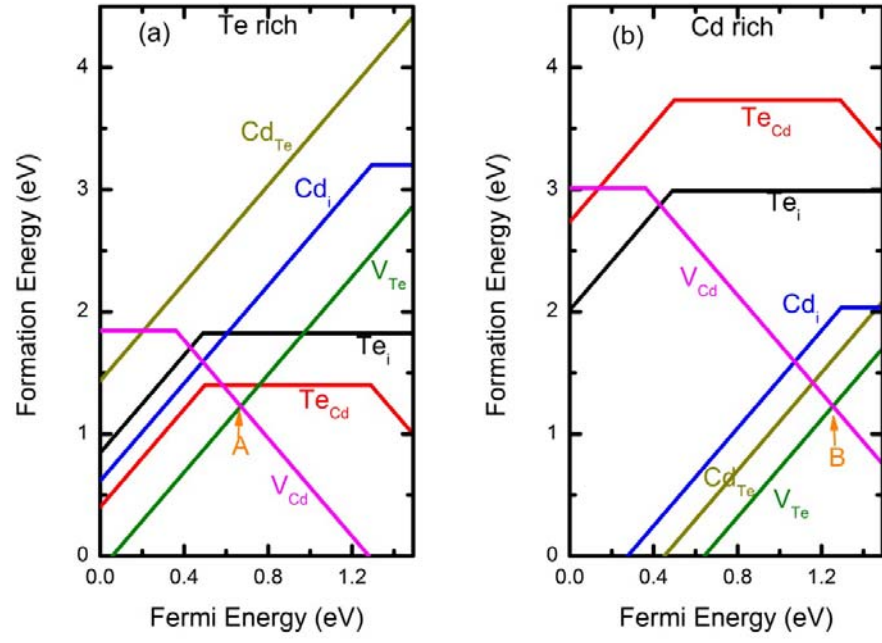


FIG. 2 (color online). Intrinsic defect formation energies versus Fermi levels in CdTe under (a) Te rich conditions and (b) Cd-rich conditions.

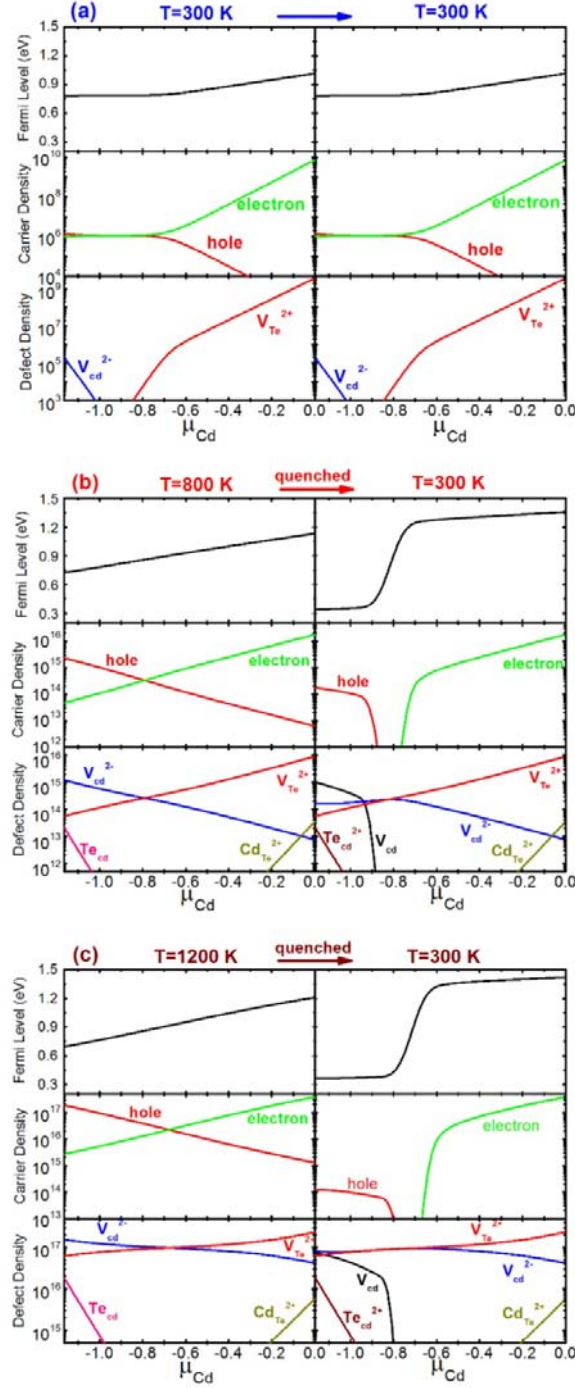


FIG. 3 (color online). Fermi level, carrier density, and defect density as functions of Cd chemical potential under thermodynamic equilibrium growth condition are shown in the left panels of (a) at  $T=300\text{ K}$ , (b) at  $T=800\text{ K}$ , and (c) at  $T=1200\text{ K}$ . The right panels of (a), (b), and (c) show the quenched (to  $T=300\text{ K}$ ) Fermi level, carrier density, and defect density as functions of Cd chemical potential.



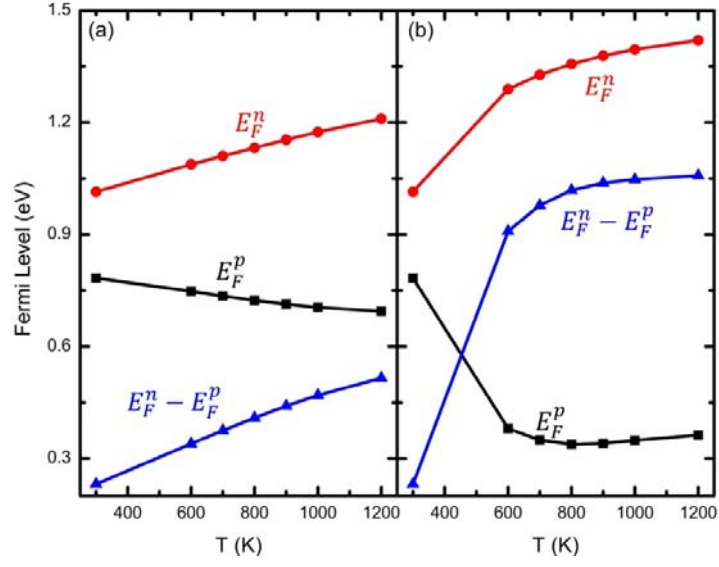


FIG. 4 (color online). (a) Under thermodynamic equilibrium conditions,  $E_F^p$  (under Cd-poor condition),  $E_F^n$  (under Cd-rich condition), and their differences  $E_F^n - E_F^p$  as a function of growth temperatures. (b) The same properties after quenching to room temperature.